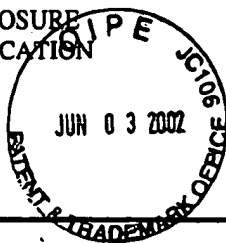


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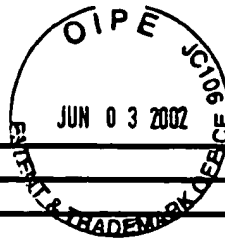
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CITATION IN AN APPLICATIONDOCKET NUMBER  
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Andrew Rodney FerlitschFILING DATE:  
January 31, 2002GROUP ART UNIT  
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